



93  
B1 IFW

# TRANSMITTAL OF FORMAL DRAWINGS

Docket No.  
OKI.298

In Re Application Of: **Hirokazu Hayashi**

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/059,176	January 31, 2002	A. Saxena	20987	2128	7695

Invention: **METHOD FOR MODELING SEMICONDUCTOR DEVICE PROCESS**

Address to:  
**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

Transmitted herewith are:

9 sheets of formal drawing(s) for this application.

☐ Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

*Signature*

**ANDREW J. TELESZ, JR.  
REG. NO. 33,581**

**VOLENTINE FRANCOS & WHITT, P.L.L.C.  
11951 FREEDOM DRIVE, SUITE 1260  
RESTON, VA 20190  
TEL. NO. (571) 283-0720**

Dated: **December 27, 2006**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

(Date)

*Signature of Person Mailing Correspondence*

*Typed or Printed Name of Person Mailing Correspondence*